2002 8

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appleants:

Thomas R. Omstead and Karl B. Levy

Assignee:

Novellus Systems, Inc.

Title:

Atomic Layer Deposition Systems and Methods

Serial No.:

10/028,610

Filing Date:

December 19, 2001

Examiner:

unknown

Group Art Unit:

1765

Docket No.:

M-11953 US

San Francisco, California July 1, 2002

COMMISSIONER FOR PATENTS

Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the paraminer for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

- 1. an admission that the documents are necessarily prior art-with respect to the instant invention;
 - 2. a representation that a search has been made; or
- 3. an admission that the information listed herein is, or is considered to be, material to patentability as defined in § 1.56(b).

EXPRESS MAIL LABEL NO:

EL 947 823 636 US

Respectfully submitted,

3 W. WW

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Sheet 1 of 1

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U.S. Department of commerce, Parent and Trademark Office					M-11953 US		Sérial (No. 10/028,61)		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicants		14/		
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			IIS P	atent Documents					
*Examiner		Document		l local Booms			Filing D		
Initial		Number	Date	Name	Class	Subclass	If Approp	riate	
	AA	4,976,996	Dec. 11, 1990	Monkowski et al.					
	AB	5,770,469	Jun. 23, 1998	Uram et a.					
	AC								
	AD						 		
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		Document	Date	Country	Class	Subclass	Yes	No	
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		OTHER	ART (Including A	Author, Title, Date, P	ertinent Pages, E	tc.)			
Examiner				Date Considered d, whether or not citation is in conformance with MPEP 609; Draw line through					